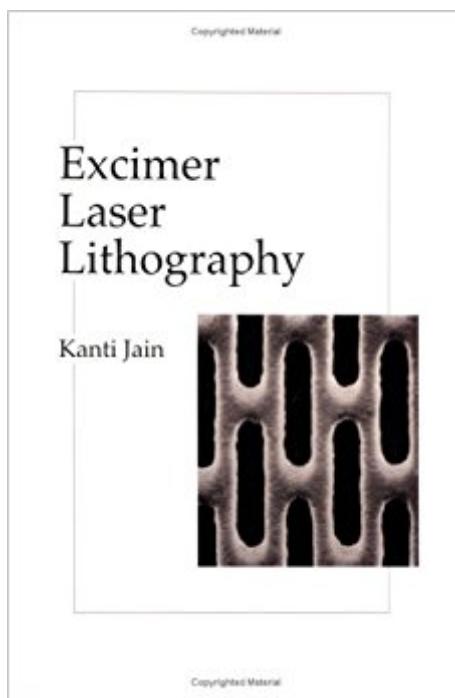


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Book Information

Paperback: 214 pages

Publisher: SPIE Publications (February 1, 1990)

Language: English

ISBN-10: 0819402710

ISBN-13: 978-0819402714

Product Dimensions: 0.5 x 7.2 x 10.2 inches

Shipping Weight: 1.1 pounds (View shipping rates and policies)

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